

Patent

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**CENTRAL FAX CENTER**  
**MAY 16 2007**

Customer No.: 31561  
Application No.: 10/605,160  
Docket No. 11439-US-PA

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : WEN-PIN CHIU  
Application No. : 10/605,160  
Filed : September 12, 2003  
For : IONIZED PHYSICAL VAPOR DEPOSITION PROCESS  
Art Unit : 1753  
Examiner : MCDONALD, RODNEY GLENN

**TRANSMITTAL LETTER**  
**+1-571-273-8300**  
**(Via fax: 1+2+9 pages)**

ASSISTANT COMMISSIONER FOR PATENTS  
Alexandria, VA 22314

Dear Sir,

In response to the Final Office Action dated February 20, 2007, please find the relevant papers as follows:

- ☒ Request for Continued Examination in (2) pages;
- ☒ Preliminary Amendment in (9) pages.

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,  
JIANQ CHYUN Intellectual Property Office

Date: May 16, 2007

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